



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Jeffrey W. Carr

Appln. No.: 10/608,384

Confirm. No.: 1758

Filed: June 27, 2003

Title: APPARATUS AND METHOD FOR REACTIVE  
ATOM PLASMA PROCESSING AND MATERIAL  
DEPOSITION

### PATENT APPLICATION

Art Unit: 1765

Examiner: Vinh, Lan

Docket No. CARR-1001US4

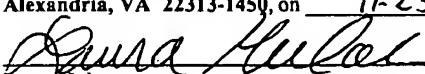
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### CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 11-23-05.

  
Laura Hulac (Signature)

### REPLY TO OFFICE ACTION UNDER 37 C.F.R. § 1.113

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

### INTRODUCTORY COMMENTS

This Reply is in response to the Final Office Action dated August 23, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.

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Atty. Docket No.: CARR-01000US4 SRM/DTX  
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